2 1006 g ocket No. 2942566526PCT MAIL STOP PCT

Docket No. 294256 S26PCT

IN REXPLICATION OF: Shuuichi ISHIZUKA, et al.

SERIAL NO.

46/587,394 July 27, 2006

FOR:

METHOD FOR CLEANING PROCESS CHAMBER OF SUBSTRATE PROCESSING APPARATUS,

SUBSTRATE PROCESSING APPARATUS, AND METHOD FOR PROCESSING SUBSTRATE

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR

Transmitted herewith is an amendment in the above-identified application.

☒ No additional fee is required

☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.

Additional documents filed herewith: Preliminary Amendment

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA - CLAIMS	RATE			CALCULATIONS	
TOTAL	20	MINUS 20 0		х	\$50	=	\$0.00		
INDEPENDENT	4	MINUS	4	0	х	x \$200 =		\$0.00	
APPLICATION SIZE	MINUS 100 0 (each addtl. 50 shee		0 (each addtl. 50 sheets)	х	\$250	=	\$0.00		
☐ MULTIPLE DEPENDENT CLAIMS						\$360	=	\$0.00	
TOTAL OF ABOVE CALCULATIONS						\$0.00			
☐ Reduction by 50% for filing by Small Entity							\$0.00		
TOTAL							\$0.00		

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Credit card payment form is attached to cover the fees in the amount of \$0.00

Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

SHUUICHI ISHIZUKA, ET AL. : ATTN: APPLICATION DIVISION

SERIAL NO: 10/587,394

FILED: JULY 27, 2006

FOR: METHOD FOR CLEANING

PROCESS CHAMBER OF SUBSTRATE PROCESSING APPARATUS, SUBSTRATE

PROCESSING APPARATUS, AND METHOD FOR PROCESSING

SUBSTRATE

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to a first examination on the merits, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.